

Notice of References Cited	Application/Control No. 10/584,927		Applicant(s)/Patent Under Reexamination YAMAMOTO ET AL.	
	Examiner GUINEVER S. GREGORIO		Art Unit 1793	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2006/0231015	10-2006	Meguro et al.	117/084
*	B	US-2003/0131787	07-2003	Linares et al.	117/93
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 01071771	11-1990	Japan	Horikoshi Yoshiharu	
	O					
	P					
	Q					
	R					
	S					
	I					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	May; CVD Diamond- A New technology for the Future?; School of Chemistry, Iniverity of Bristol, Bristol BS8 1TS, U.K.
	V	Landstrass et al. Device Properties of Homoepitaxially Grown Diamond; Diamond and Related Materials; 2, pages 1033-1037; 1993
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.